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(f/k/a D900D/1368D)

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PATENT
U.S. Ser. No. 10/079,775

\$2823
#51B
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Suler

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Plat, et al.
Serial No.: 10/079,775
Conf. No.: 9123
Filed: February 19, 2002
Title: Method and System for Reducing ARC layer Removal During Removal of Photoresist
Art Group: 2823
Examiner: Lee, Hsien Ming.

Mail Stop: Fee Amendment
Commissioner of Patents
P. O. Box 1450
Alexandria, VA 22313-1450

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Michael Adams
Signature

Michael P. Adams
Printed Name

5/20/03
Date

RESPONSE TO OFFICE ACTION

In response to the Office Action mailed November 20, 2002 (Paper 3), Applicants respectfully request that the Examiner reconsider the rejection of the claims in view of the amendments and comments set forth herein.

In the Specification:

Please replace the current Title with:

WSM Docket No.
184-P057D1
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